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Date: <u>August 31, 2001</u> Docket No.: <u>0630-1187P</u>

Assistant Commissioner for Patents Box PATENT APPLICATION Washington, D.C. 20231

Sir:

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As authorized by the inventor(s), transmitted herewith for filing is a patent application applied for on behalf of the inventor(s) according to the provisions of 37 CFR 1.41(c).

Inventor(s): KANG, Tae-Woong

For: METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

Enclosed are:

X	A specification consisting of 19 pages
X	5 sheet(s) of <u>formal</u> drawings
X	Certified copy of Priority Document(s)
X	Executed Declaration in accordance with 37 CFR 1.64 will follow
	Applicant claims small entity status in accordance with 37 CFR 1.27
_	Preliminary Amendment

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<u>X</u>	Information Sheet
	Information Disclosure Statement, PTO-1449 with reference(s)
	Application Data Sheet in accordance with 37 CFR 1.76
	Other
	Applicant requests early publication

The filing fee has been calculated as shown below:

LARGE ENTITY SMALL ENTITY

FOR	NO. FILED	NO. EXTRA	RATE	FEE		RATE	FEE
BASIC FEE	********	********* ******	**** ****	\$710.00	or	* * * * * * * * * * * *	\$355.00
TOTAL CLAIMS	20 - 20 =	0	x18 =\$	0.00	or	x 9 =	\$ 0.00
INDEPENDENT	3 - 3 =	0	x80 =\$	0.00	or	x 40 =	\$ 0.00
MULTIPLE D	+270 =	\$ 0.00	or	+135 =	\$ 0.00		

TOTAL \$ 710.00 TOTAL \$ 0.00

- The application transmitted herewith is filed in accordance with 37 CFR 1.41(c). The undersigned has been authorized by the inventor(s) to file the present application. The original duly executed patent application together with the surcharge will be forwarded in due course.
- \underline{X} A check in the amount of \$\frac{710.00}{1000}\$ to cover the filing fee and recording fee (if applicable) is enclosed.
- The Government Filing Fee will be paid at the time of completion of the filing requirement.
- Please charge Deposit Account No. 02-2448 in the amount of \$____. A triplicate copy of this transmittal form is enclosed.

Send Correspondence to:

BIRCH, STEWART, KOLASCH & BIRCH, LLP or Customer No. 2292 P. O. Box 747 Falls Church, Virginia 22040-0747 Telephone: (703) 205-8000

No fee is enclosed.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

Ву_

Reg. No. 35,416 P. O. Box 747

Falls Church, Virginia 22040-0747

(703) 205-8000 GDY/nv

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KANG, Tae-Woong

Application No.:

Filed: August 31, 2001

Group:

For:

METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

LETTER

Honorable Commissioner of Patents

Washington, D.C. 20231

August 31, 2001 0630-1187P

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s): Country

REPUBLIC OF KOREA

Application No. 2000-51214

<u>Filed</u>

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP By:

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IN THE U.S. PATENT AND TRADEMARK OFFICE

INFORMATION SHEET

Applicant:

KANG, Tae-Woong

Application No.:

Filed:

August 31, 2001

For:

METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY KOREA DATE

NUMBER

08/31/00

2000-51214

Send Correspondence to:

BIRCH, STEWART, KOLASCH & BIRCH, LLP

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Falls Church, Virginia 22040-0747

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The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By.

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